## Refine Search

## Search Results -

Terms	Documents
L4 and (hot wire or (hot near2 filament) or HWCVD)	27

US Pre-Grant Publication Full-Text Database

US Patents Full-Text Database US OCR Full-Text Database

Database:

EPO Abstracts Database JPO Abstracts Database Derwent World Patents Index

IBM Technical Disclosure Bulletins

Search:

L5	

Refine Search

Recall Text 👄

Clear

Interrupt

## **Search History**

DATE: Friday, January 23, 2004 Printable Copy Create Case

Set Name	<u>Query</u>	Hit Count	<u>Set Name</u>
side by side	2		result set
DB=PC	GPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR=YES	S; OP=ADJ	
<u>L5</u>	L4 and (hot wire or (hot near2 filament) or HWCVD)	27	<u>L5</u>
<u>L4</u>	L1 and (filament same vacuum same temperature)	216	<u>L4</u>
<u>L3</u>	L1 and (filament same vacuum)	504	<u>L3</u>
<u>L2</u>	L1 and filament	1119	<u>L2</u>
<u>L1</u>	118/720-733.ccls.	14356	<u>L1</u>

END OF SEARCH HISTORY